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APPLICANTS Mitsuhiro Ichijo, Tochigi, JAPAN; Taketomi Asami, Kasukabe, JAPAN; Kunihiro Fukuchi, Atsugi, JAPAN; Satoshi Toriumi, Ebina, JAPAN;						
** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** JAPAN 2003-076646 03/19/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/03/2004						
Foreign Priority claimed 35 USC 119(a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No /LONG PHAM/ Examiner's signature	<input type="checkbox"/> Met after Allowance LP Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 8	TOTAL CLAIMS 33	INDEPENDENT CLAIMS 4
ADDRESS NIXON PEABODY, LLP 401 9TH STREET, NW SUITE 900 WASHINGTON, DC 20004-2128 UNITED STATES						
TITLE Film formation method and manufacturing method of semiconductor device						
FILING FEE RECEIVED 4790	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		